

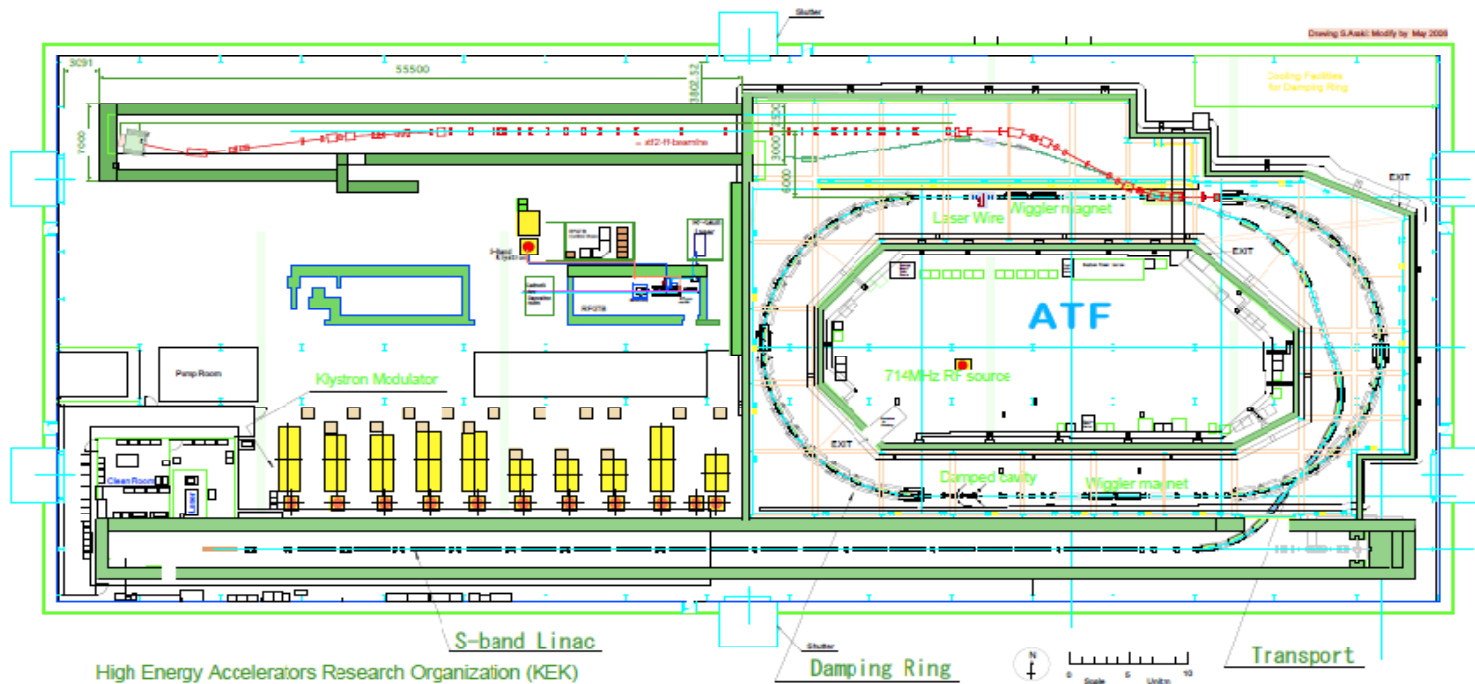
FD configuration, especially S-band BPMs

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3 / 17 / 2008

ATF2 meeting in KNU

Introduction - ATF2 Project



Beam energy

$$E_{\text{beam}} = 1.3 \text{ GeV}$$

Emittances

$$\varepsilon_x = 2 \times 10^{-9} \text{ m}$$

$$\varepsilon_y = 1 \times 10^{-11} \text{ m}$$

Beta Function at IP

$$\beta_x^* = 4 \text{ mm}$$

$$\beta_y^* = 0.1 \text{ mm}$$

Beam Size at IP

$$\sigma_x^* = 2.8 \text{ } \mu\text{m}$$

$$\sigma_y^* = 34 \text{ nm}$$

-Prototype of ILC Final Focus Optics.

- Initial commissioning will be started from the end of 2008.

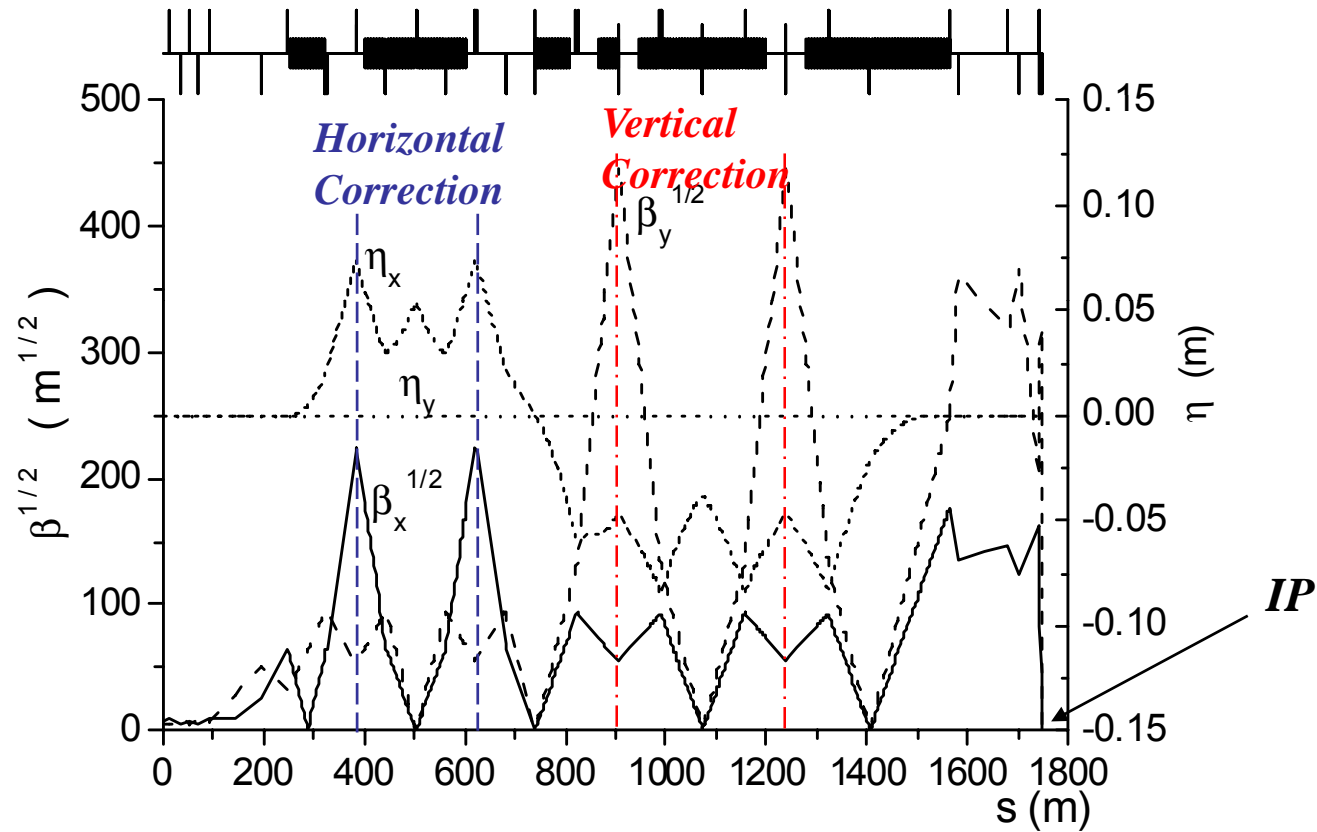
Design Parameters of ATF2

Parameters	ILC	FFTB	ATF-II
E_{beam} [GeV]	250 / 500	46	1.3
N_{bunch}	2×10^{10}	5×10^{10}	1×10^{10}
$\gamma\varepsilon_x$ [radm]	1×10^{-5}	3×10^{-5}	2.5×10^{-6}
$\gamma\varepsilon_y$ [radm]	4×10^{-8}	2×10^{-6}	5.0×10^{-8}
β_x^* [mm]	21 / 30	3.0	4.0
β_y^* [mm]	0.4 / 0.3	0.1	0.1
L^* [m]	3.5 or 4.3	1.5	1.0
σ_x^* [μm]	0.66 / 0.55	1	2.8
σ_y^* [nm]	5.7 / 3.5	47	34

***-FFTB with global chromaticity correction scheme,
was tested in 1993-1997 and achieved the smallest beam size of 55nm.***

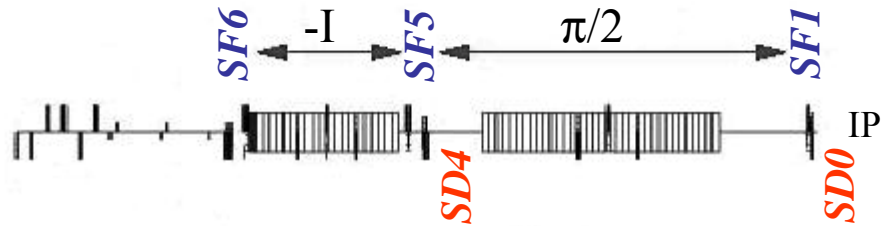
***- ATF2, the ILC BDS test facility with local chromaticity correction method,
will be tested from the end of 2008***

Beam Optics for Global Chromaticity Correction (Old Linear Collider Final Focus)



Chromaticity correction was done only by global correction section.

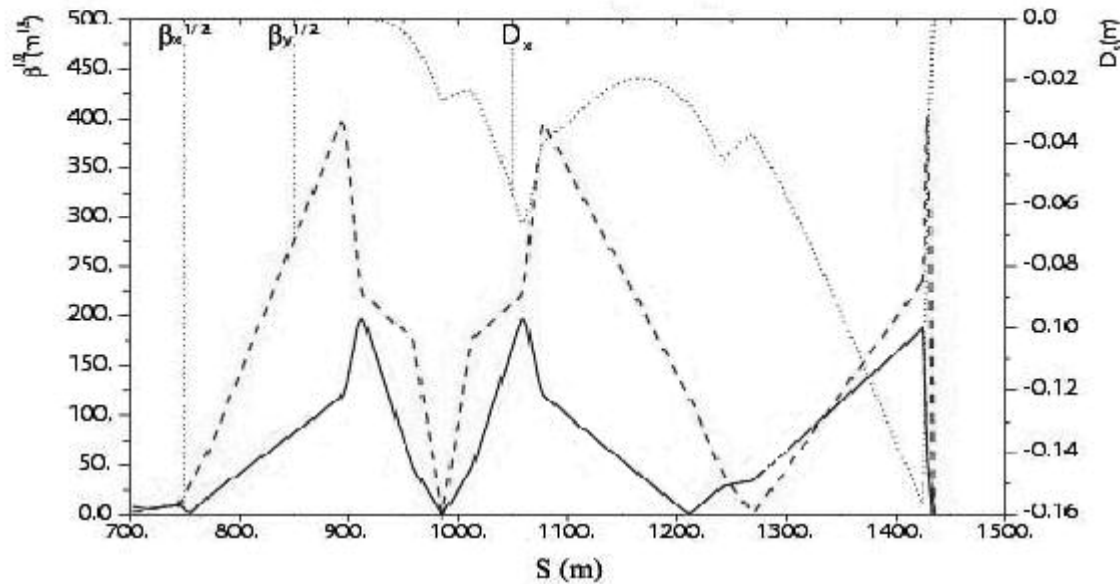
Beam Optics for Local Chromaticity Correction (Present ILC Final Focus)



Main Correction Items (coupled)

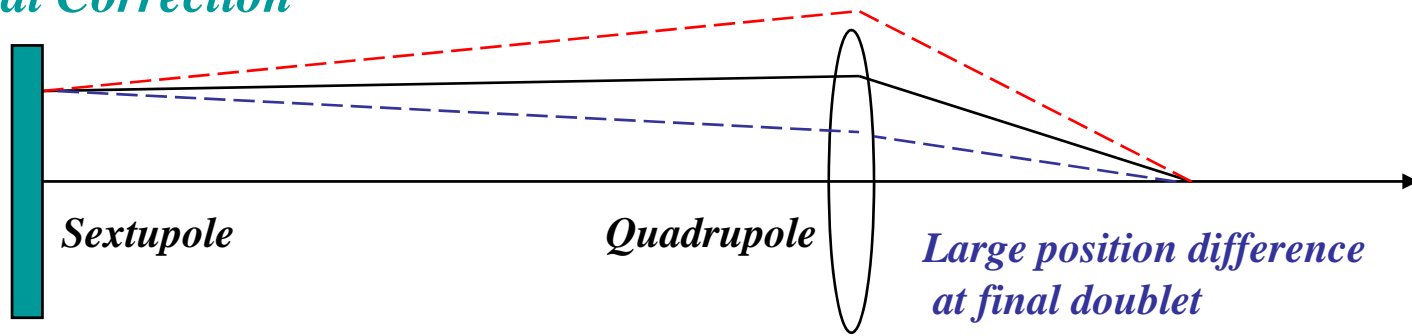
*Horizontal Correction
2nd order Dispersion Correction*

Vertical Correction

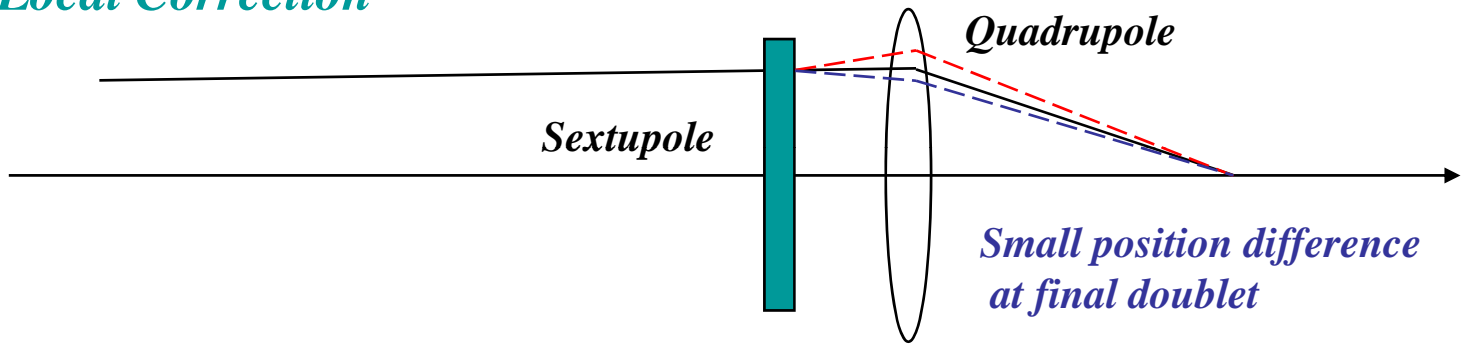


Sextupoles are located around the quadrupoles, which generate the large chromaticity.

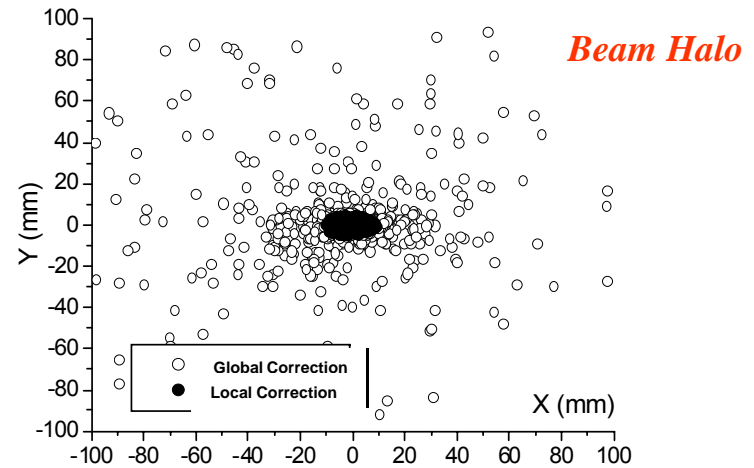
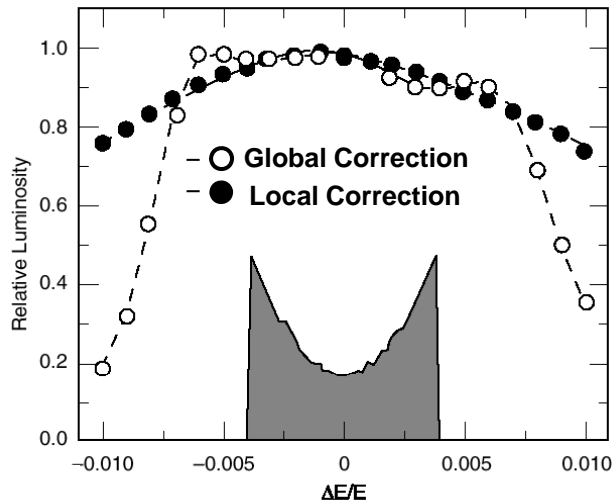
Global Correction



Local Correction

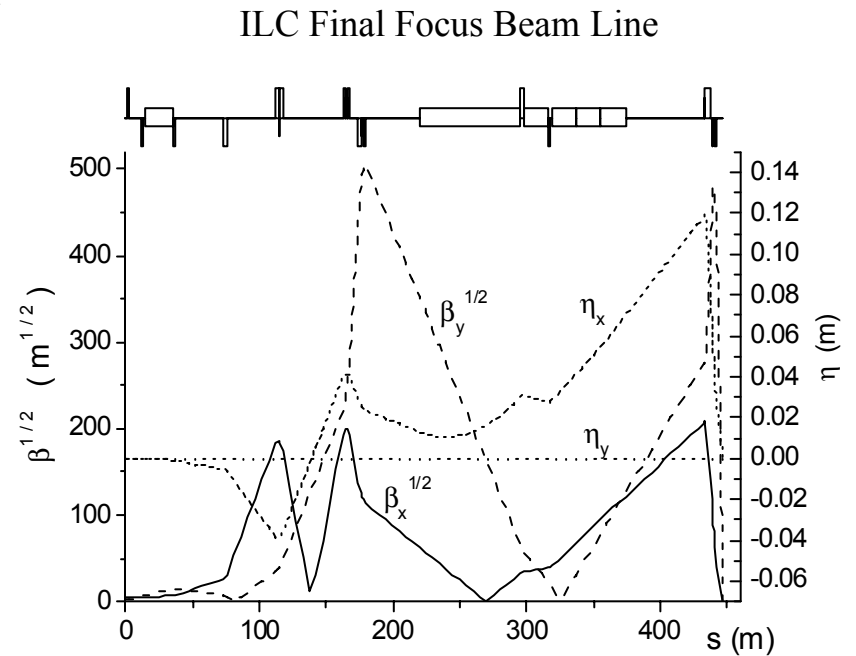
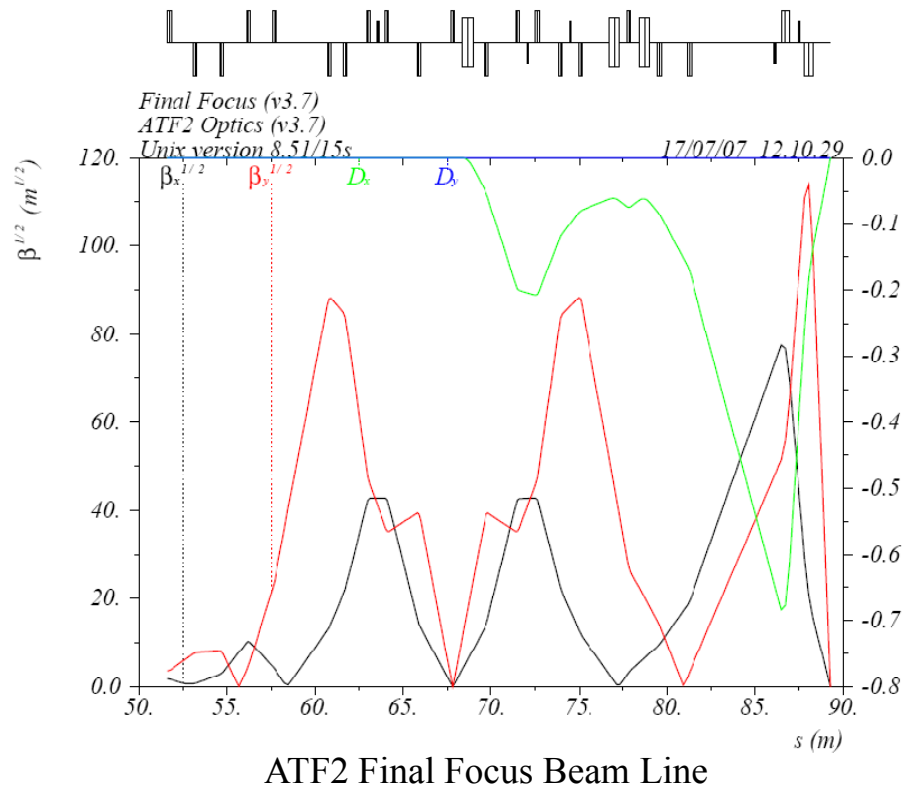


Bandwidth



ATF2 Optics

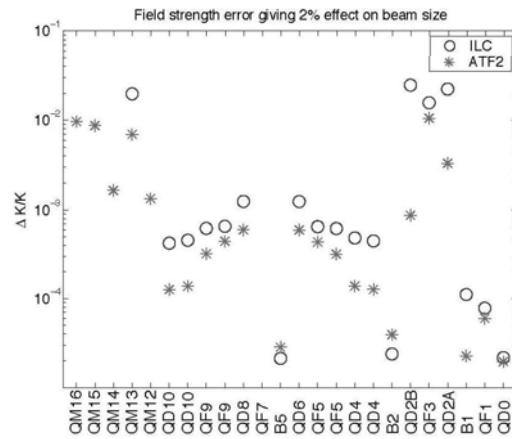
**-Prototype of ILC final focus beam line
(Local Chromaticity Correction)**



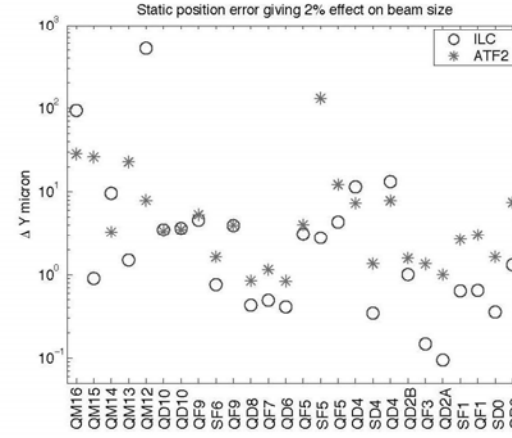
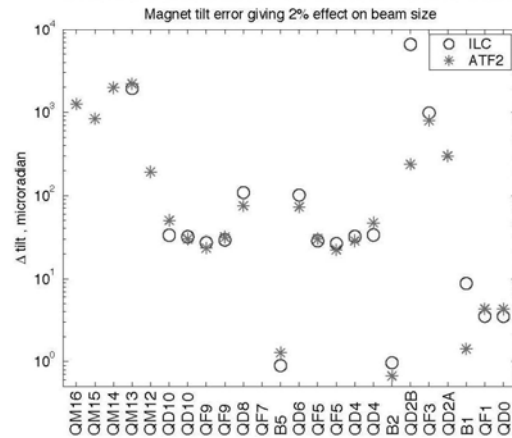
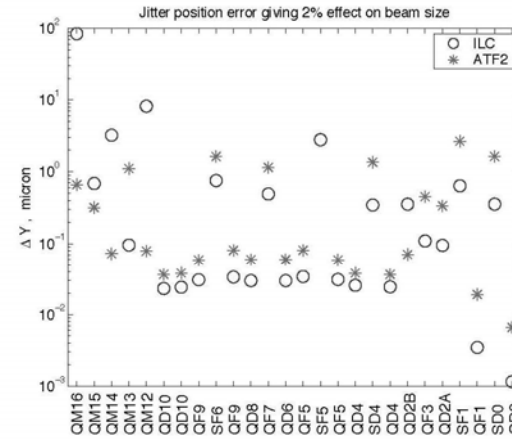
Alignment and Vibration Tolerance

The tolerance of ATF2 quadrupoles are same order to that of ILC BDS.

Strength of Quadrupoles



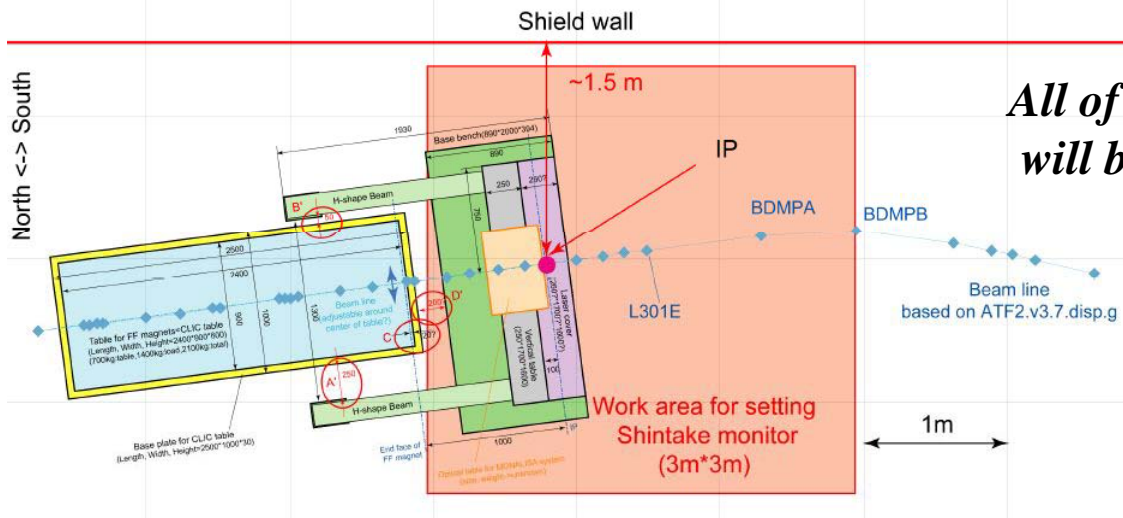
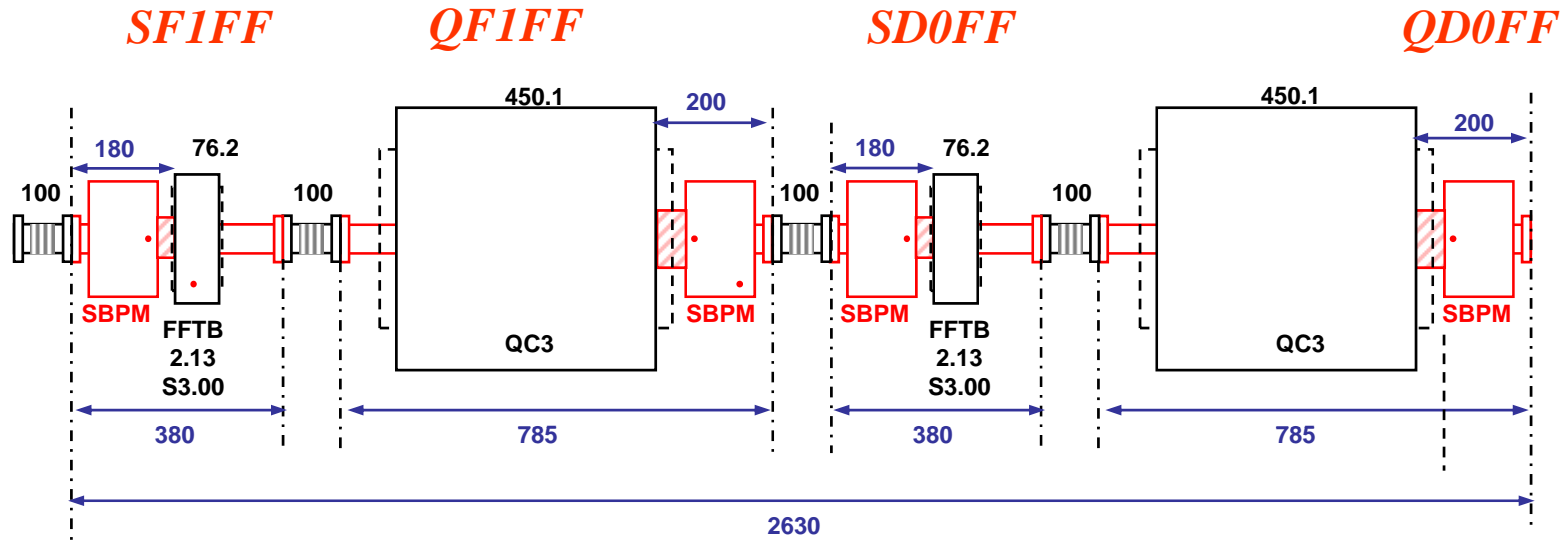
Vibration of Quadrupoles



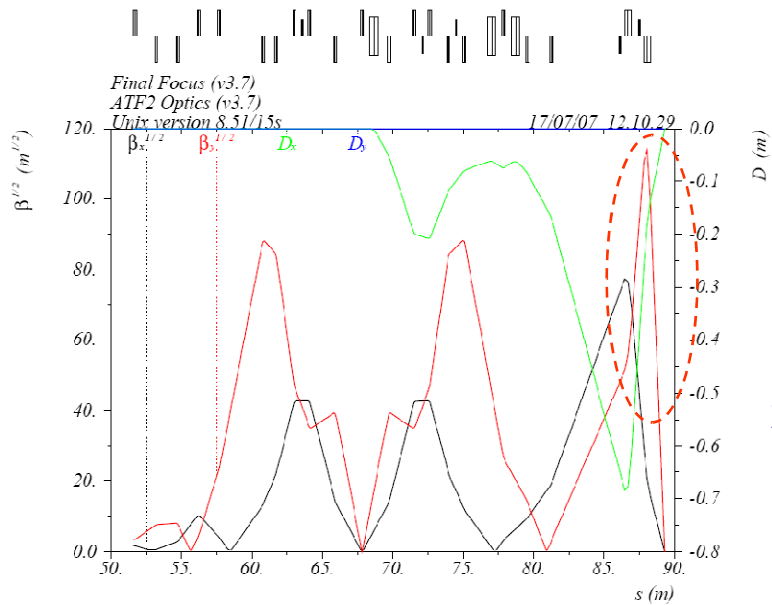
Rotation of Quadrupoles

Position Alignment of Quadrupoles

Final Doublet Table Configuration



*All of the Components
will be mounted to one support table.
(prepared by LAL)*

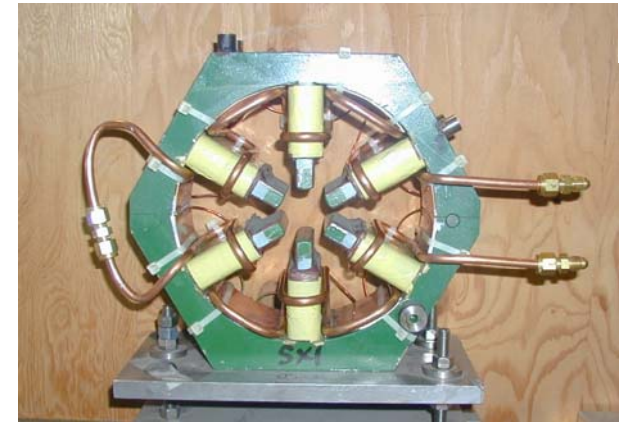


Sextupoles to use SD0 and SF1

*Large Beam size
around “Final Doublet”*

$$\sigma_x = 3.6 \mu\text{m}$$

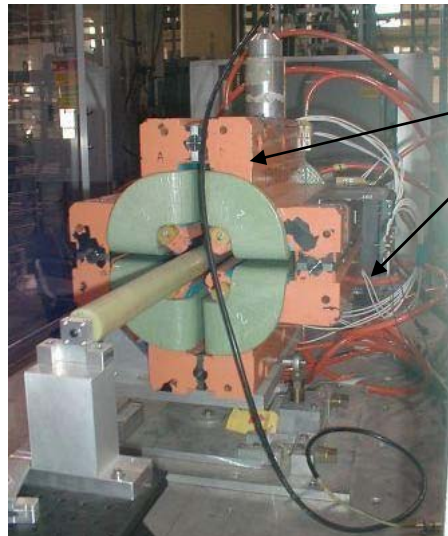
*The large beam size make
a background to
“Shintake Monitor”*



Bore diameter: 2.1259” = 54mm

Final Doublet Quadrupoles

Modified the SLAC QC3 magnet to make the large aperture



*Shims to make
a large aperture*

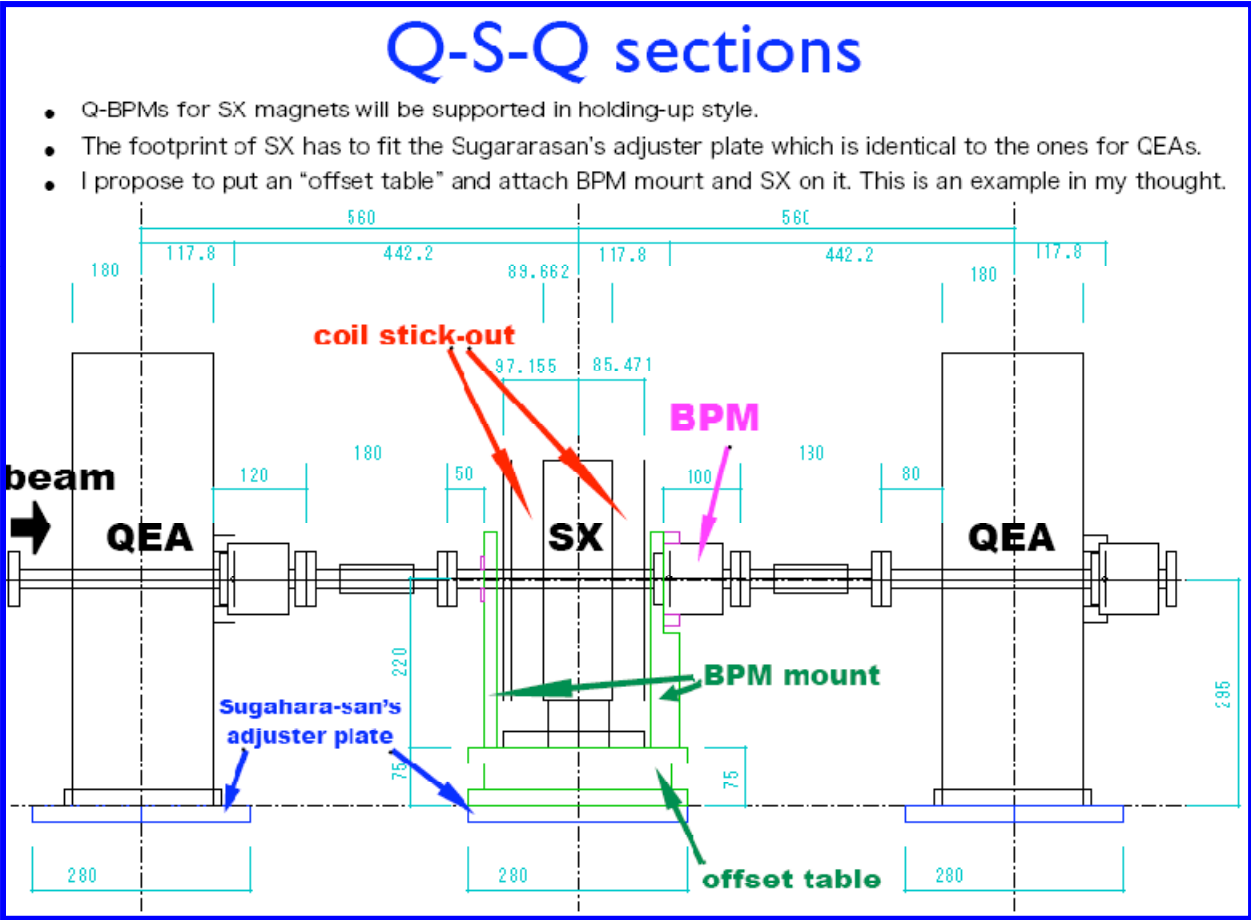
*Side-shim
to reduce 12-pole*



*S-band BPM will be used around the Final Doublet
and Sextupoles to make a large aperture.*

We must make the S-band BPM support adopter for SF1 and SD0, because the weight of S-band BPMs are heavy.

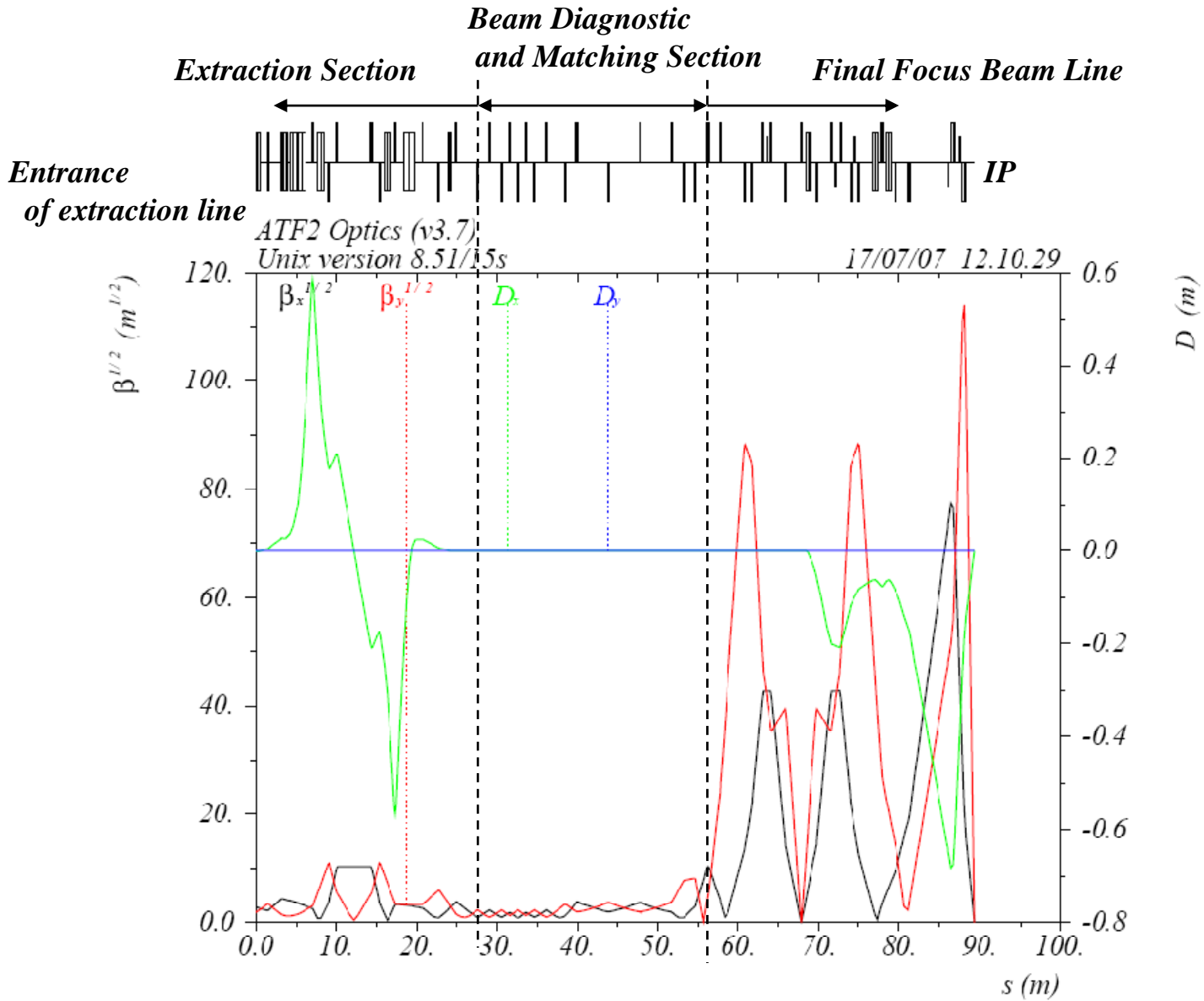
Example of the BPM support



This is not the supports for SF1 and SD0

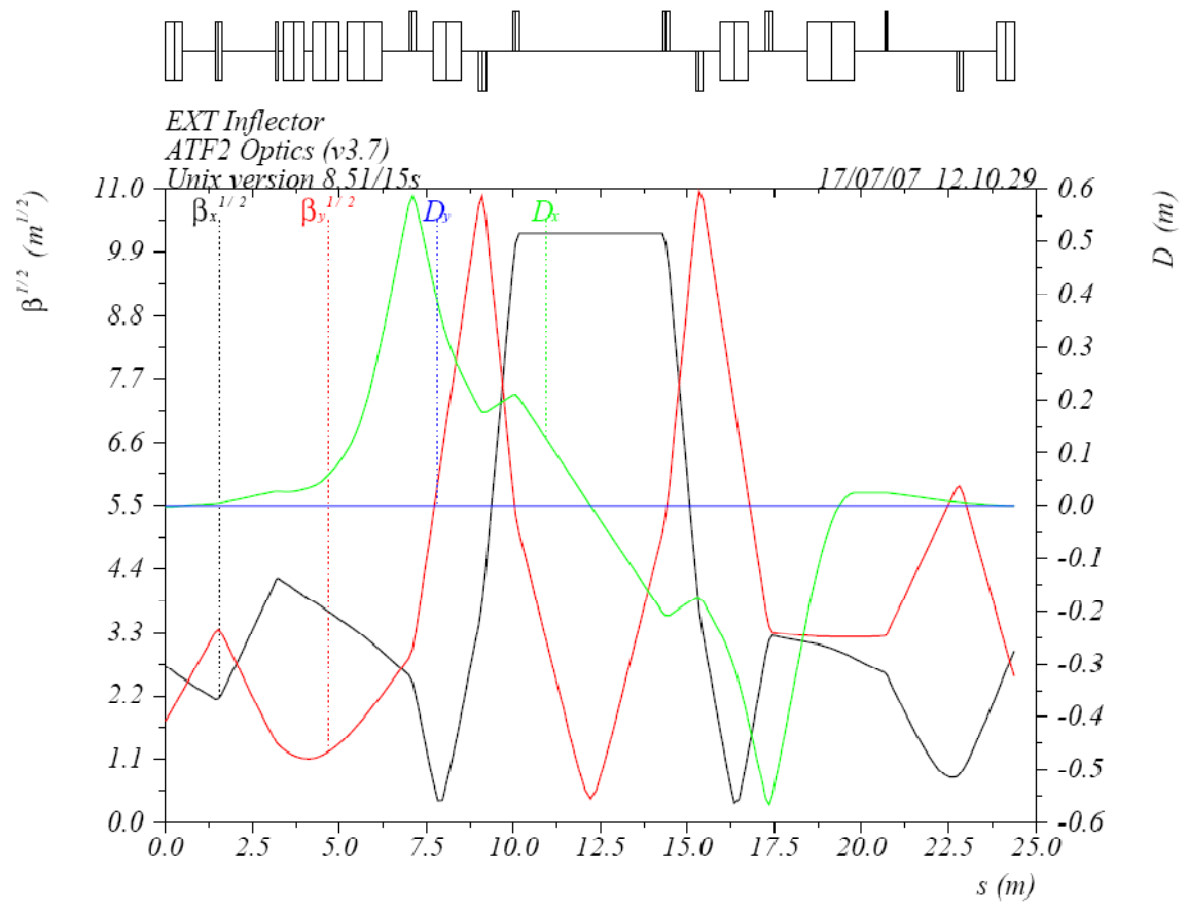
End of presentation

ATF2 Optics



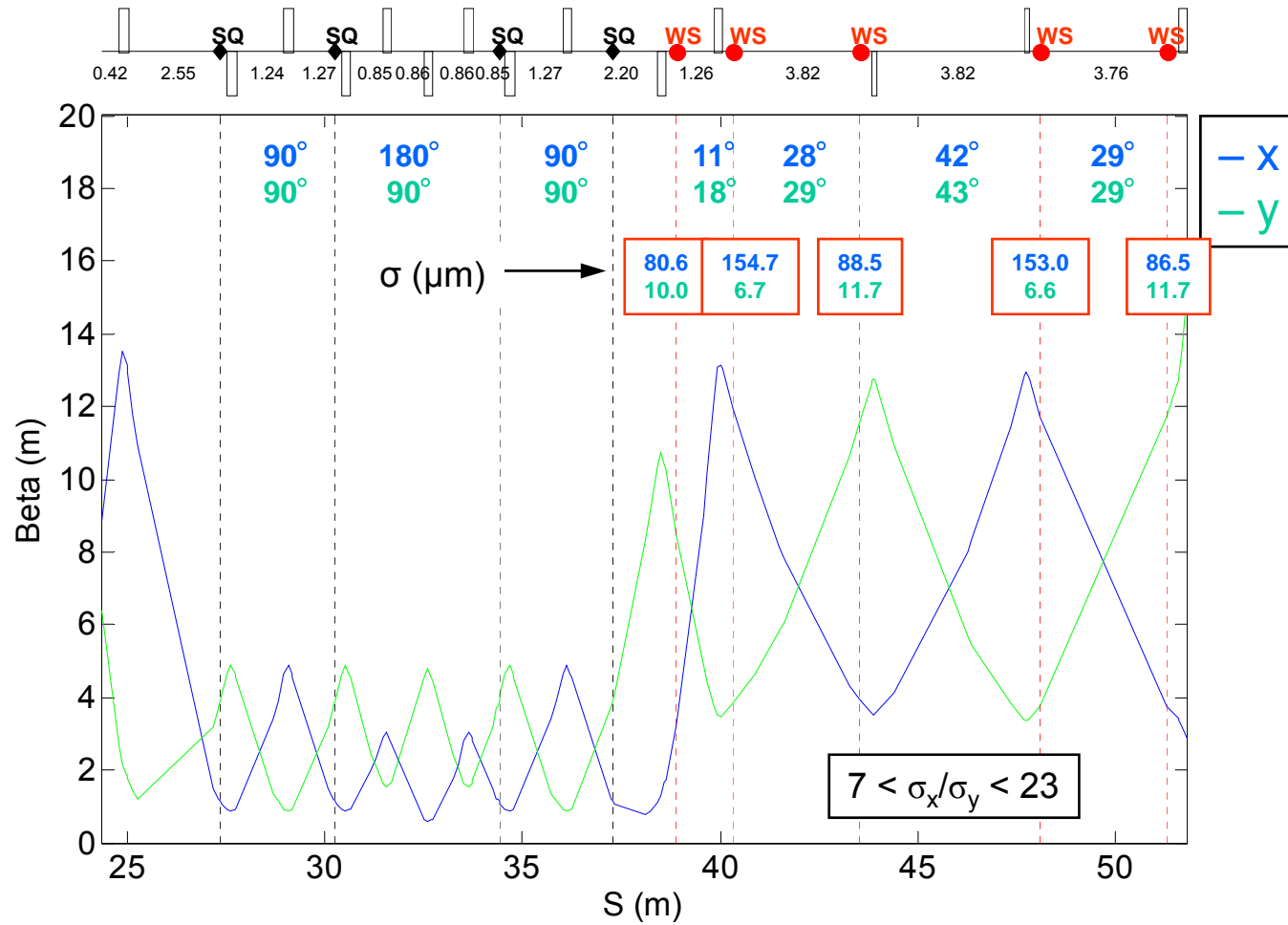
Extraction Section

- *Renewal of present ATF extraction line to reduce the maximum dispersion*
- *Dispersion correction*
- *Extraction kicker jitter correction by double kicker system*



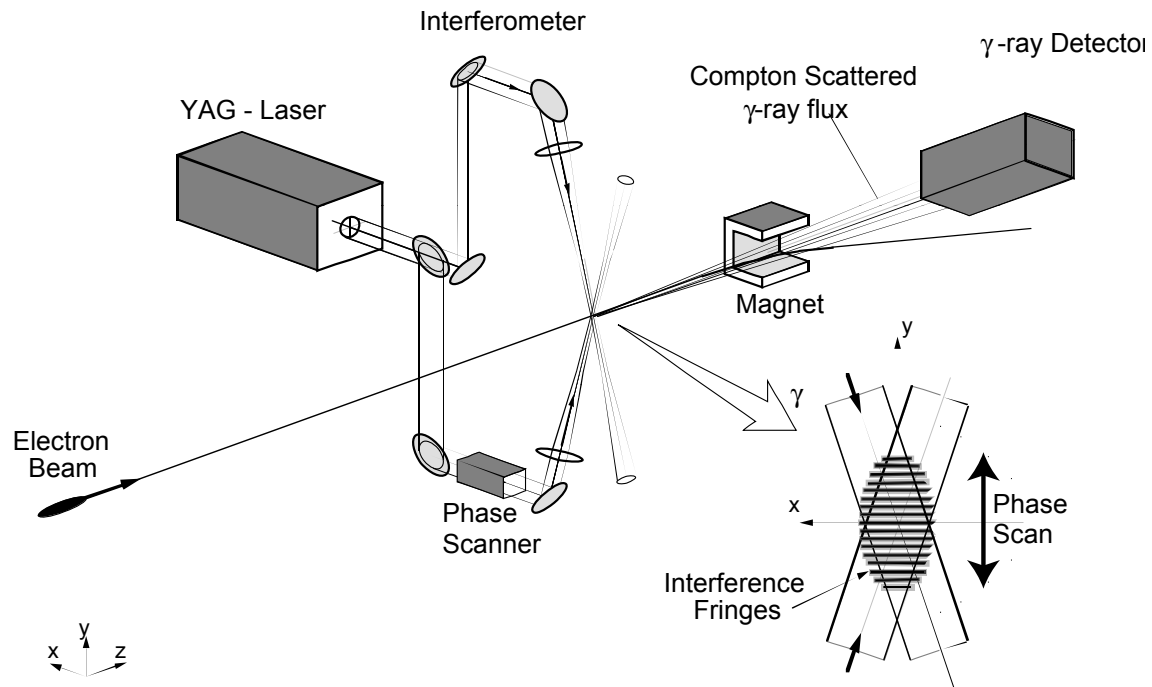
Beam Diagnostic and Matching Section

- Emittance measurement with wire scanners
- Coupling correction with skew quadrupoles
- Matching to Final Focus beamline



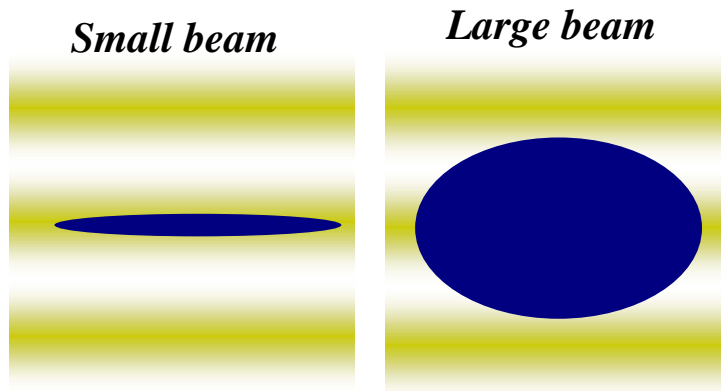
Beam size measurement in ATF2

Small Beam Size was measured with Laser Interferometer (Shintake Monitor)



Since the beamstrahlung

Beam Size Evaluation by Shintake Monitor

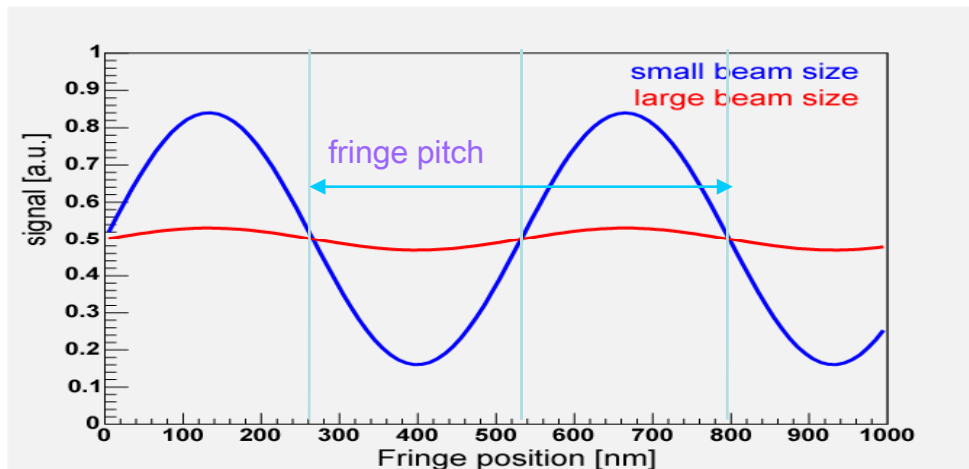


Emitted photon distribution

$$N_{\gamma} \propto \int_{-\infty}^{\infty} \exp\left[-\frac{(y-y_0)^2}{2\sigma_y^2}\right] (1 + \cos\theta \cos 2k_y y) dy$$

$$= N_0 [1 + \cos(2k_y y_0) \cos\theta] \exp[-2(k_y \sigma_y)^2]$$

$$N_{\pm} = N_0 [1 \pm \cos\theta \exp[-2(k_y \sigma_y)^2]]$$



$$M \equiv \frac{N_+ - N_-}{N_+ + N_-}$$

$$= |\cos\theta| \exp[-2(k_y \sigma_y)^2]$$

$$= |\cos\theta| \exp[-2\left(\frac{\pi \sigma_y}{d}\right)^2]$$

$$\sigma_y = \frac{d}{2\pi} \sqrt{2 \ln \left(\frac{|\cos\theta|}{M} \right)}$$

Amount of interference

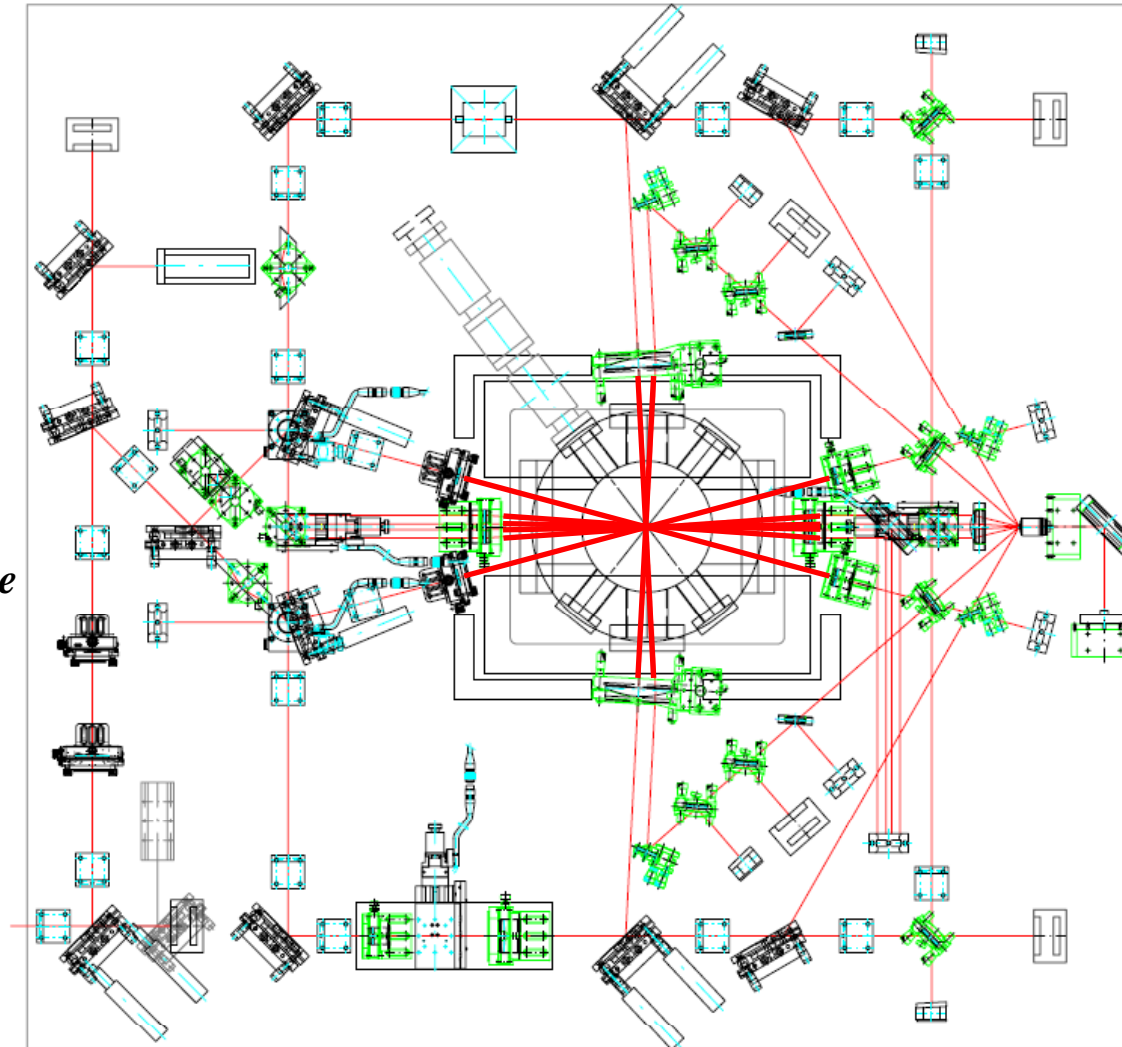
Layout of the Laser Table

2 degree mode

8 degree mode

30 degree mode

174 degree mode



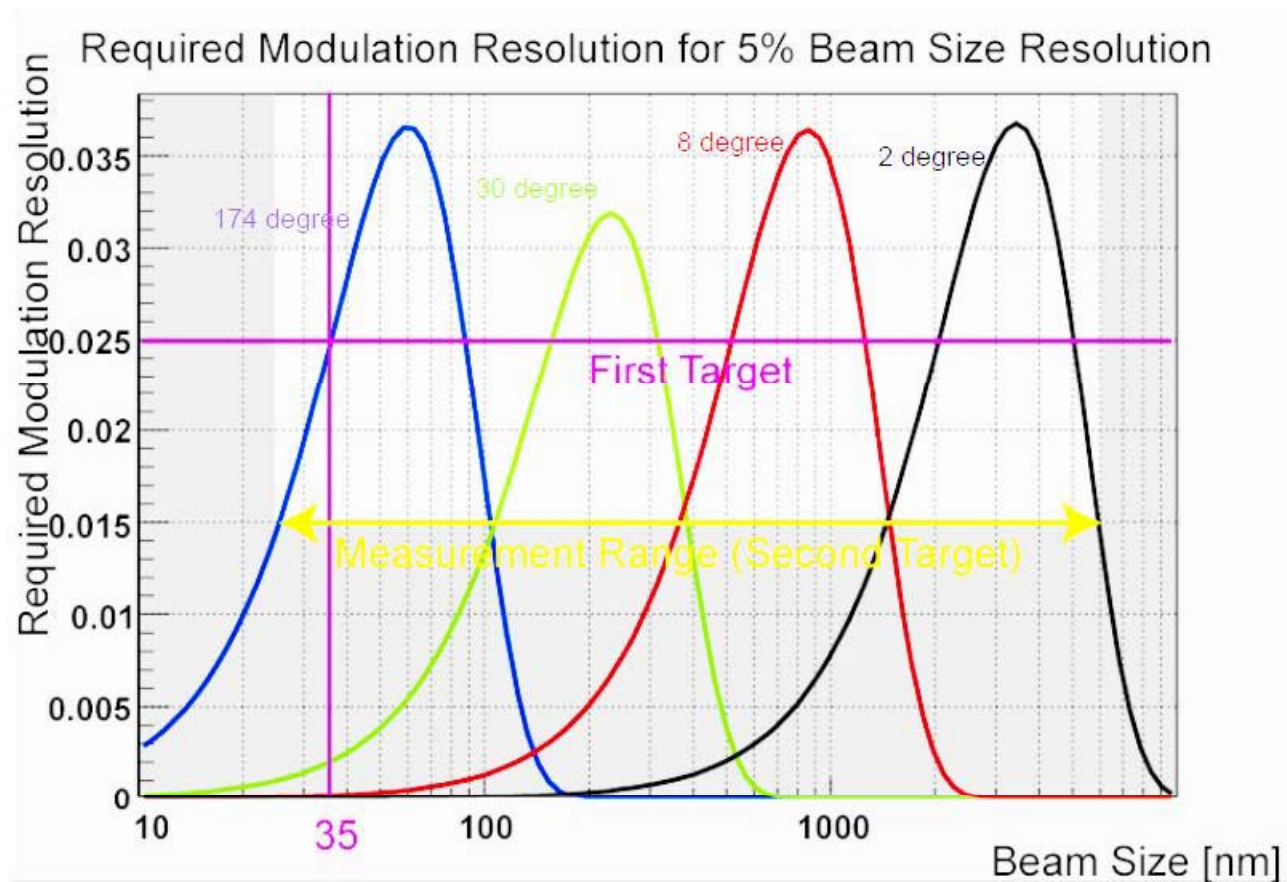
15 μ m pitch

3.8 μ m pitch

1.03 μ m pitch

266nm pitch

Measurable Range of Laser Interferometer



*By changing 4 laser collision angle,
we can measure 25 – 6000 nm of beam size.*